

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/623,866 Confirmation No. : 6399
First Named Inventor : Yoshihiro KATO
Filed : July 22, 2003
TC/A.U. : 1763
Examiner : J. Lund

Docket No. : 101246.52582US
Customer No. : 23911

Title : Plasma Process System and Plasma Process Method

SUPPLEMENTAL AMENDMENT AND RESPONSE

Mail Stop AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to a telephone conversation with the Examiner and supplemental to the Amendment and Response under 37 C.F.R. §1.116 filed June 17, 2008, Applicant submits herewith the following Supplemental Amendment and Response.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this Response.

Remarks begin on page 7 of this Response.